# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

plicant:

L.M. Nicholson et al.

Title:

Improved Chemical Planarization Performance for Copper/Low-k

Interconnect Structures

Filed:

July 28, 2003

Serial No.:

10/628,925

Examiner:

Hung K. Vu

Art Unit:

2811

Docket No.:

YOR920030173US1

**Customer No.:** 

22032

Confirmation No.:

7501

# **Mail Stop Amendment**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

# **AMENDMENT**

Dear Sir:

Transmitted herewith is Response to the Office Action dated December 30, 2004, in the above-identified application.

Request for extension of time pursuant to 37 C.F.R. §§ 1.136 and 1.137 is
hereby made if, and to the extent, required. The fee for this extension of time is
calculated to be \$ to extend the time for filing this response until
The fee for any change in number of claims has been calculated as shown below.

CLAIMS AS AMENDED							
	Claims Remaining After Amendment		Highest Number Previously Paid	Present Extra	Rate		
Total Claims	31	Minus	50	0	x \$50.00	\$	
Independent Claims	2	Minus	2	0	x \$200.00	\$	
MULTIPLE DEPENDENT CLAIM FEE				x \$360.00 = \$			
TOTAL FEE FOR CLAIM CHANGES				\$0.00			
1/2 FILING FEE FOR SMALL ENTITY						\$N/A	

The total fee for this a time is calculated to be \$		ding claim changes, and is included.	l any extension of				
sheets of amended dr	awings are enclo	sed;					
XXX The Commissioner is additional fees under 37 C.F communication or during the overpayment, to <b>Deposit Ac</b>	R. §§1.16 and 1. entire pendency	17 which may be require of the application, or cre	ed with this				
A duplicate copy of th	is Form is enclose	ed.					
		Respectfully submitted	d,				
Date: March 30, 2005	By:	Paul D. Greeley Reg. No. 31,019 Attorney for Applicant( Ohlandt, Greeley, Rug & Perle, L.L.P. One Landmark Square Stamford CT 06901-2 Tel: 203-327-4500 Fax: 203-327-6401	igiero e, 10 <sup>th</sup> Floor				
CERTIFICATE OF MAILING							
I HEREBY CERTIFY TO WITH THE U.S. POSTAL SE ADDRESSED TO: MAIL STOP P.O. BOX 1450, ALEXANDR	RVICE AS FIRST DP AMENDMENT	, COMMISSIONER FO	NVELOPE R PATENTS,				
Vazken A. Alexanian NAME		SIGNATURE DATE					

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### **AMENDMENT**

#### Dear Sir:

In response to the Office Action dated December 30, 2004, please amend this application as follows: